APPLICATION TRANSMITTAL under 37 CFR 1.53(h)) Toshiaki ONO, Tadami TANAKA, Eiichi ASAYAMA, T Hideshi MISHIKAWA and Masataka HORAI Express Mail Label No. APPLICATION ELEMENTS FOR: METHOD OF MANUFACTURING EPITAXIAL WAFER AND METHOD OF PRODUCING SINGLE CRYSTAL AS MATERIAL THEREFOR 1. [XX] Fee Transmittal Form (Incorporated within this form) (Submit an original and a duplicate for fee processing) 2. [XX] Specification Total Pages [34] 3. [XX] Drawing(s) (35 USC 113) Total Pages [2] 3. [XX] Onth or Declaration Total Pages [2] 3. [XX] Onth or Declaration Total Pages [2] 3. [XX] Newly executed (original) 4. [] Detelion of Inventor(a) Signed sattement attached deleting inventor(a) named in prior application. see 37 CFR 1.60(h)(2) and 1.33(h). 5. [] Incorporation by reference (useable if box 4b is checked) The entire disclosure of the prior application, from which a copy of the oath or declaration is supplied under Box 4b, is considered as being part of the disclosure of the accompanying application and is hereby incorporated by reference therein. 6. [] Microfiche Computer Program (Appendix) 7. [] Nucleotide and/or Amino Acid Sequence Submission (if applicable, all necessary) a. [] Computer Readable Copy b. [] Paper Copy (identical to computer copy) c. [] Statement Verifying identity of above copies ACCOMPANYING APPLICATION PARTS [XX] Assignment Papers (cover sheet and document(s)) to: Sumitomo Metal Industries, Ltd., Osaka-shi, Japan Please publish the assignee data with the application.	UTILITY PATENT	Attorney Docket No.	010789	Total Pages	S. F	
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9. [] 37 CFR 3.73(b) Statement (when there is an assignee) [XX] Power of Attorney						
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UTILITY PATENT APPLICATION TRANSMITTAL

(Only for new nonprovisional applications under 37 CFR 1.53(b))

TOTAL

Attorney Docket No.

010789

First Named Inventor or Application Identifier

Toshiaki ONO, Tadami TANAKA, Eiichi ASAYAMA, Hideshi NISHIKAWA and Masataka HORAI

\$1812.00

PAGE 2 OF 3

10. [] English translation Document (if appli	cable)					
11. [XX] Information Disclosure Statement	[XX] Copies of	IDS Citations (PTO-144	49 & 4 Ref.)			
12. [] Preliminary Amendment						
13. [XX] Return Receipt Postcard (MPEP 503)						
14. [] Small Entity Status is claimed.						
15. [XX] Claim for Convention Priority [2] Certified copies of Priority Documents are enclosed.						
a. Priority of <u>Japanese</u> application No. <u>2000-188176</u> filed on <u>June 22, 2000</u> is claimed under 35 USC 119. b. Priority of <u>Japanese</u> application No. <u>2000-190631</u> filed on <u>June 26, 2000</u> is claimed under 35 USC 119.						
216. [] Other			_			
17. If a CONTINUING APPLICATION, check appropriate box and supply the requisite information:						
[] Continuation [] Division [] Continuation-in-part (CIP) of prior application no/						
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<u> </u>						
FEE TRANSMITTAL	Number Filed	Number Extra	Rate	Basic		
The filing fee is calculated below				Fee \$710.00		
Total Claims	24 - 20	4	x \$18.00	\$72.00		
Independent Claims	12 - 3	9	x \$80.00	\$720.00		
Multiple Dependent Claims \$270.00				\$270.00		
		E	Basic Filing Fee	\$1772.00		
Reduction by 1/2 for small entity			-			
Fee for recording enclosed Assignment			\$40.00	\$40.00		

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PAGE 3 OF 3

- [XX] A check in the amount of \$1812.00 is enclosed to cover the filing fee including \$710.00 basic filing fee; \$72.00 for 4 extra clailms; \$720.00 for 9 extra independent claims; \$270.00 for multiple dependent claims and the assignment recordation fee of \$40.00.
- [] Please charge our Deposit Account No. 01-2340 in the total amount of ______ to cover the filing fee and the _____ assignment recordation fee. A duplicate of this sheet is attached.
- [XX] The Commissioner is hereby authorized to charge payment for any additional filing fees required under 37 CFR 1.16 or credit any overpayment to Deposit Account No. 01-2340. A duplicate of this sheet is attached.
- 18. CORRESPONDENCE ADDRESS:



23850

PATENT TRADEMARK OFFICE

SUBMITTED BY

Typed or Printed Name // Stephen G. Adrian

Reg. No. 32,878

Signature

Date: June 20, 2001

Tel: (202) 659-2930 Fax: (202) 887-0357